

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8728**  
Norio KIMURA et al. : Attorney Docket No. 2000\_1761A  
Serial No. 09/742,386 : Group Art Unit 1792  
Filed December 22, 2000 : Examiner Karla A. Moore  
APPARATUS AND METHOD FOR : **Mail Stop: RCE**  
PROCESSING SEMICONDUCTOR  
SUBSTRATE

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of February 20, 2009, kindly amend the above-referenced U.S. patent application as follows: